

10/586445
AP20 Rec'd PCT/PTO 17 JUL 2006

PATENT
Attorney Docket No. 1110/97825

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application)
)
Applicant: KOZO NAKAMURA ET AL.)
)
Serial No.: Not Available)
)
Filed: July 17, 2006)
)
For: METHOD FOR PREDICTING PRECIPITATION)
BEHAVIOR OF OXYGEN IN SILICON SINGLE)
CRYSTAL, METHOD FOR DETERMINING)
PRODUCTION PARAMETER OF SILICON)
SINGLE CRYSTAL, AND STORAGE MEDIUM)
FOR STORING PROGRAM FOR PREDICTING)
PRECIPITATION BEHAVIOR OF OXYGEN IN)
SILICON SINGLE CRYSTAL)
)
Examiner: Not Available)
)
Art Unit: Not Available)

PRELIMINARY AMENDMENT

Mail Stop
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please make the following amendments, preliminary to examination of the subject application.